



INTERNATIONAL  
GEMOLOGICAL  
INSTITUTE

## ELECTRONIC COPY

### LABORATORY GROWN DIAMOND REPORT

October 31, 2025

IGI Report Number **LG741514947**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **ROUND BRILLIANT**

Measurements **9.79 - 9.82 X 5.98 MM**

#### GRADING RESULTS

Carat Weight **3.54 CARATS**

Color Grade **E**

Clarity Grade **VS 1**

Cut Grade **IDEAL**

#### ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**

Symmetry **EXCELLENT**

Fluorescence **NONE**

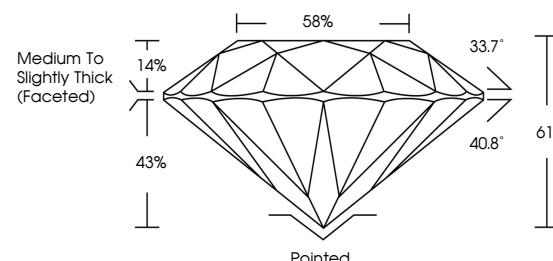
Inscription(s) **IGI LG741514947**

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.

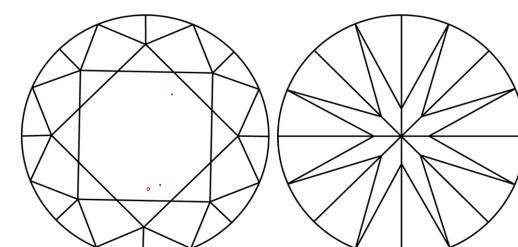
Type Ila

LG741514947  
Report verification at [igi.org](https://igi.org)

#### PROPORTIONS



#### CLARITY CHARACTERISTICS



#### KEY TO SYMBOLS

Red symbols indicate internal characteristics.

Green symbols indicate external characteristics.

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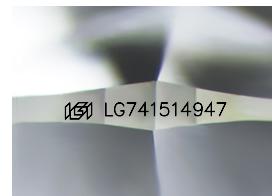
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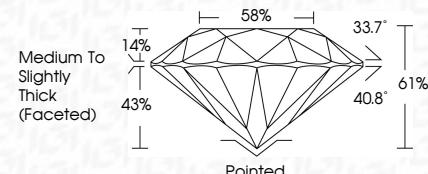
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Sample Image Used



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October 31, 2025	IGI Report No LG741514947	ROUND BRILLIANT	3.54 CARATS	E	VS 1	IDEAL	61%	69%	Medium To Slightly Thick (Faceted)	Pointed	EXCELLENT	EXCELLENT	None	IGI LG741514947	
				Carat Weight	Color Grade	Clarity Grade	Cut Grade	Depth	Table	Girdle	Polish	Symmetry	Fluorescence	Inscription(s)	
				3.54 CARATS	E	VS 1	IDEAL	61%	69%	Medium To Slightly Thick (Faceted)	Pointed	EXCELLENT	EXCELLENT	None	IGI LG741514947

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